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		U.	S. PATENT	DOCUMENTS			6 U		
*EXAMINER	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING DATE		
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1	5,676,760	10/14/97	Aoki, e	al.					
	5,762,779	6/9/98	Shiram	izu, et al.		<u> </u>			
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1	9-157692	6/17/97	Japan	,			103		
7	7-263430	10/13/95	Japan						
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Da	6-116770	4/26/94	Japan						
-	OTHER DOCUI	MENTS (Includi	ing Autho	r, Title, Date, Pertine	nt Pages, Etc.)	<u> </u>		
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Sa	A Electrochemistry H	andbook", 4th ed	ition, page	276-277.	·				
EXAMINER	Daved Ch	andhoy		DATE CONSIDERED	2/18/04	- *			
'EXAMINER:	Initial if reference considered, whe		is in confor	nance with MPEP 609; Dr			conformance	and not	

considered. Include copy of this form with next communication to applicant.

Form PTO-A820 (also form PTO-1449) POSC/REVO3

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